



# GHz-THz Electronics

Date: 07 03 2013

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*Integrity ★ Service ★ Excellence*

Report Documentation Page				Form Approved OMB No. 0704-0188	
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1. REPORT DATE <b>07 MAR 2013</b>		2. REPORT TYPE		3. DATES COVERED <b>00-00-2013 to 00-00-2013</b>	
4. TITLE AND SUBTITLE <b>GHz-THz Electronics</b>				5a. CONTRACT NUMBER	
				5b. GRANT NUMBER	
				5c. PROGRAM ELEMENT NUMBER	
6. AUTHOR(S)				5d. PROJECT NUMBER	
				5e. TASK NUMBER	
				5f. WORK UNIT NUMBER	
7. PERFORMING ORGANIZATION NAME(S) AND ADDRESS(ES) <b>Air Force Office of Scientific Research ,AFOSR/RTD,875 N. Randolph,Arlington,VA,22203</b>				8. PERFORMING ORGANIZATION REPORT NUMBER	
9. SPONSORING/MONITORING AGENCY NAME(S) AND ADDRESS(ES)				10. SPONSOR/MONITOR'S ACRONYM(S)	
				11. SPONSOR/MONITOR'S REPORT NUMBER(S)	
12. DISTRIBUTION/AVAILABILITY STATEMENT <b>Approved for public release; distribution unlimited</b>					
13. SUPPLEMENTARY NOTES <b>Presented at the AFOSR Spring Review 2013, 4-8 March, Arlington, VA.</b>					
14. ABSTRACT					
15. SUBJECT TERMS					
16. SECURITY CLASSIFICATION OF:			17. LIMITATION OF ABSTRACT <b>Same as Report (SAR)</b>	18. NUMBER OF PAGES <b>15</b>	19a. NAME OF RESPONSIBLE PERSON
a. REPORT <b>unclassified</b>	b. ABSTRACT <b>unclassified</b>	c. THIS PAGE <b>unclassified</b>			



# 2013 AFOSR SPRING REVIEW

## 3001B PORTFOLIO OVERVIEW



**NAME:** Jim Hwang

**BRIEF DESCRIPTION OF PORTFOLIO:** GHz-THz Electronics

**LIST SUB-AREAS IN PORTFOLIO:**

- I. THz Electronics** – Material and device breakthroughs for transistors based on conventional semiconductors (e.g., group IV elements or group III-V compounds with covalent bonds) to operate at THz frequencies with adequate power. Challenges exist mainly in perfecting crystalline structure and interfaces as channel thickness is scaled to single atomic layer.
- II. Novel GHz Electronics** – Material and device breakthroughs for transistors based on novel semiconductors (e.g., transition-metal oxides with ionic bonds) to operate at GHz frequencies with high power. Challenges exist mainly in controlling purity and stoichiometry, as well as in understanding metal-insulator transition.
- III. Reconfigurable Electronics** – Material and device breakthroughs for meta-materials, artificial dielectrics, ferrites, multi-ferroics, nano-magnetics, and micro/nano electromechanical systems to perform multiple electronic, magnetic and optical functions. Challenges exist mainly in understanding the interaction between electromagnetic waves, electrons, plasmons and phonons on nanometer scale.



- Sub-millimeter-wave radar & imaging
- Space situation awareness
- Chemical/biological/nuclear sensing
- Ultra-wideband communications
- Ultra-high-speed on-board and front-end data processing

- **Transition out GaN (MURI, STTR, AFRL, DARPA)**
- **Explore 2D materials and devices beyond graphene (FY14 BRI)**



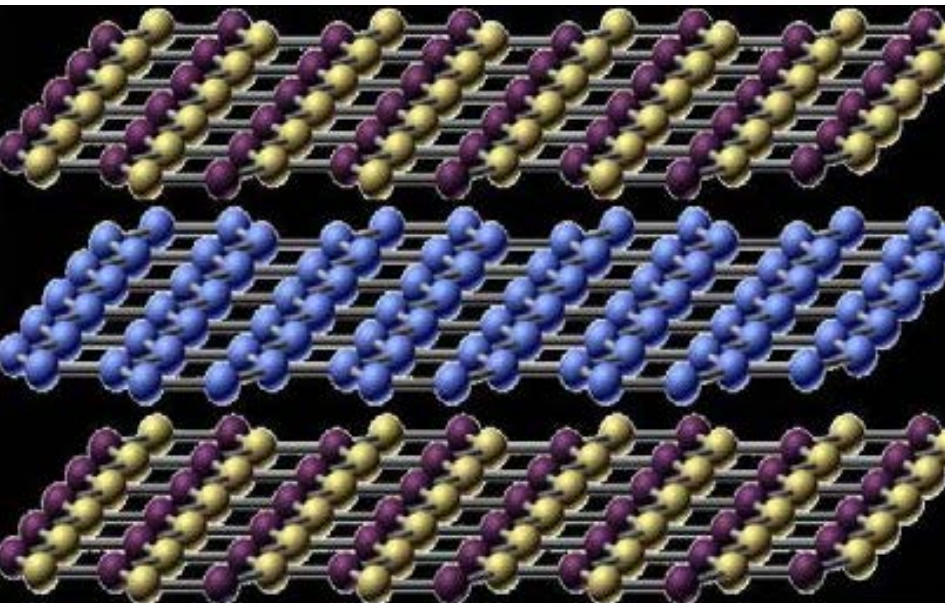
# FY14 BRI: 2D Materials & Devices Beyond Graphene

*Jim Hwang, Gernot Pomrenke, Joycelyn Harrison & Misoon Mah (AFOSR)*

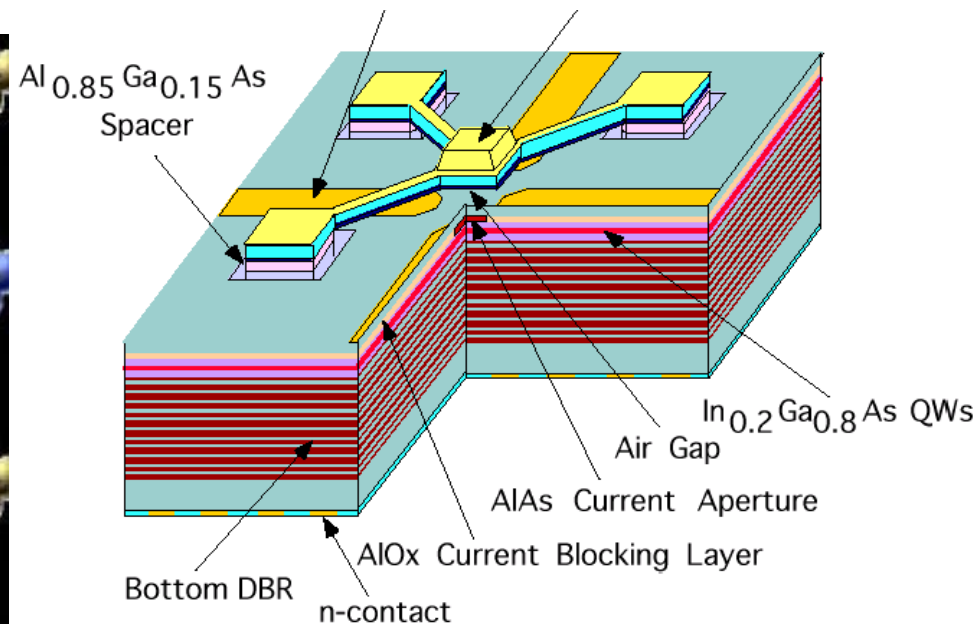


- Graphene beautiful but difficult to deal with
- Best to mate graphene with other 2D layers through van der Waals force
- Graphene – conductor, 2D BN – insulator, 2D MoS<sub>2</sub> – semiconductor, 2D NbSe<sub>2</sub> – superconductor
- Bandgap of MoS<sub>2</sub> transitions from being indirect in bulk to direct in 2D
- Free of epitaxial strains, 2D heterostructures can do more wonders than 3D heterostructures

## h-BN/Graphene/h-BN



## 3D VCSEL Heterostructure



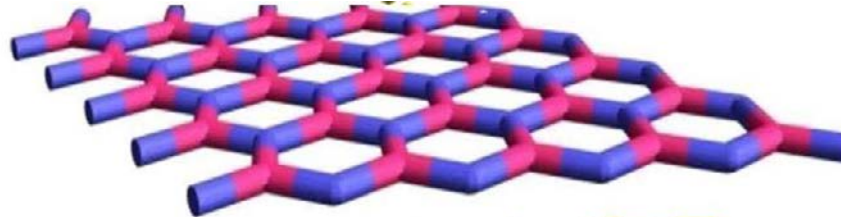




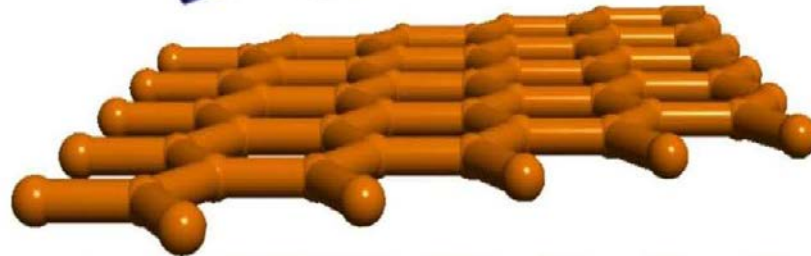
# Challenges for 2D Heterostructures



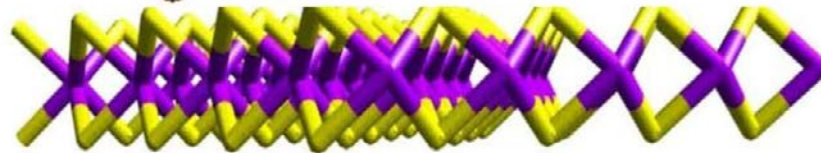
- While new 2D layers continue to be synthesized, 2D heterostructure is in infancy
- Only graphene grown on BN substrate have comparable properties to that of exfoliated graphene
- Limited success for growing 2D BN on graphene without metal catalyst
- Little theoretical understanding/prediction of properties of 2D heterostructures



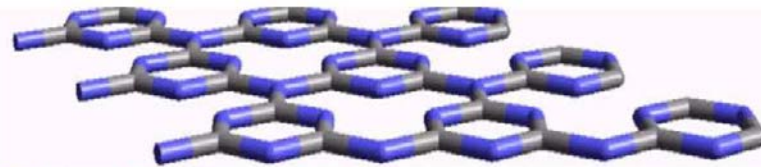
BN



graphene



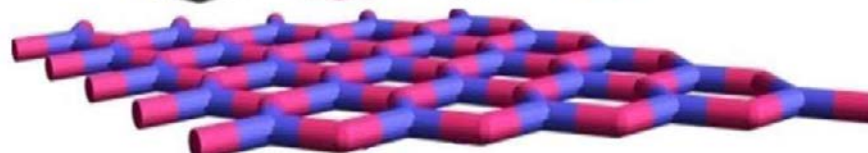
MoS<sub>2</sub>



C<sub>3</sub>N<sub>4</sub>



BC<sub>2</sub>N

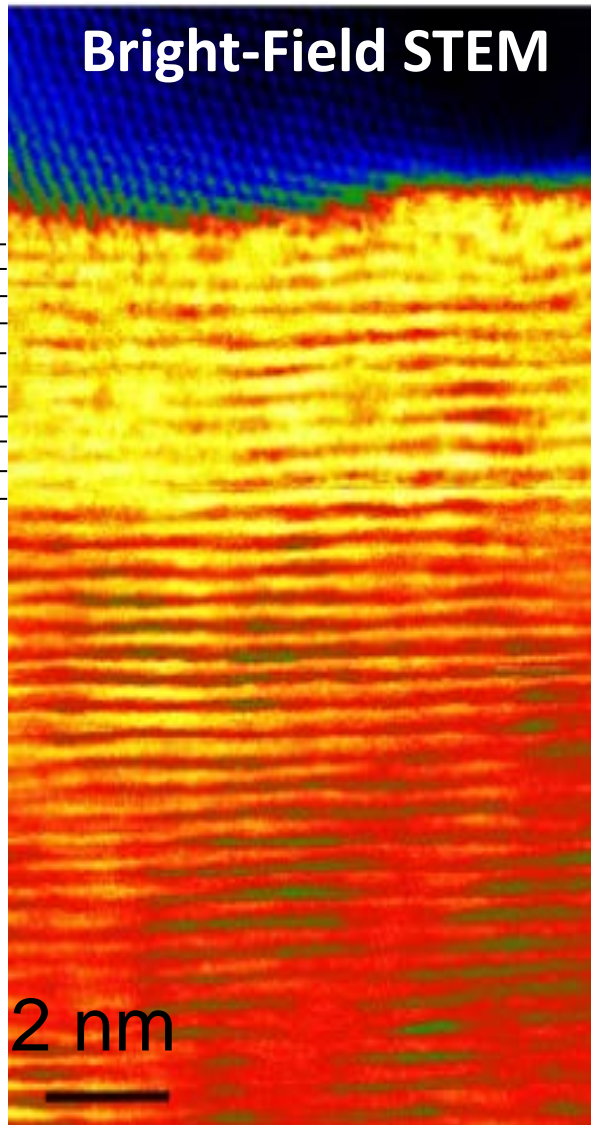
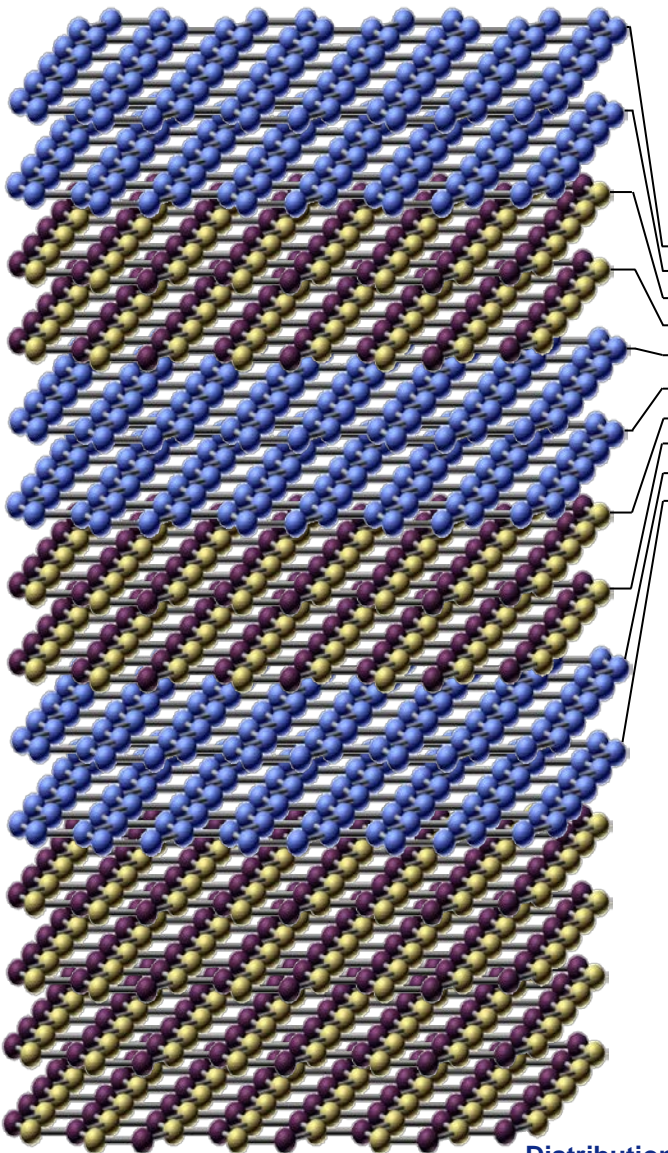


BN



# Graphene-BN Superlattice

*Andre Geim & Konstantin Novoselov (Manchester, UK)*



Remarkable  
achievement  
by exfoliation



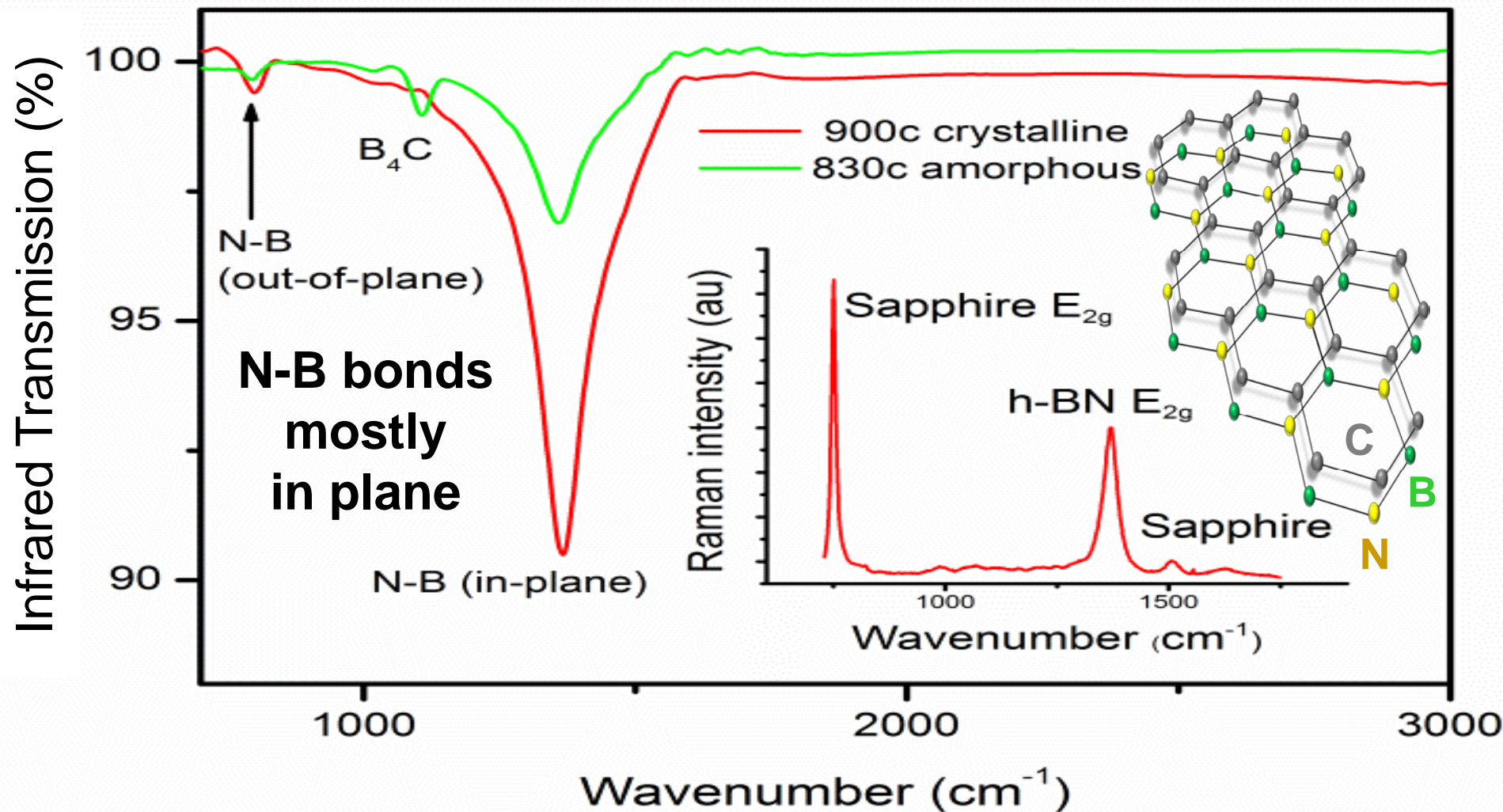
[cmilli.com](http://cmilli.com)





# Atomic Layer Deposition of Hexagonal BN on Sapphire

Mike Snure & Qing Paduano (AFRL/RYPDH)



Compared to state of the art by metal-organic chemical vapor deposition, atomic layer deposition promises monolayer control without metal catalyst





# Molecular Beam Epitaxy of $\alpha$ -Sn on InSb

## *Arnold Kiefer & Bruce Claflin, AFRL/RYPH*

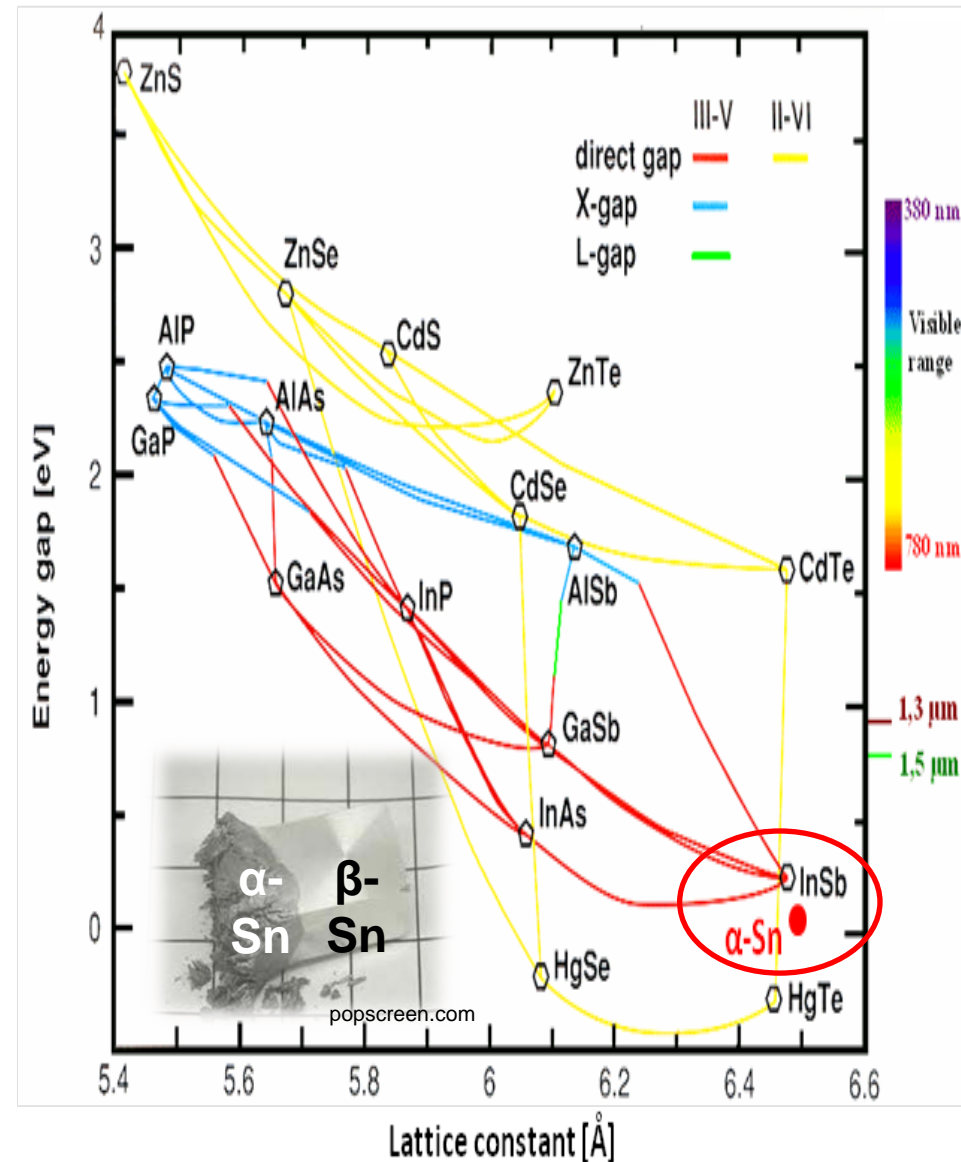


### Unique Properties of $\alpha$ -Sn

- Bulk  $\alpha$ -Sn (cubic, zero-gap semiconductor) transforms into  $\beta$ -Sn (tetragonal, metal) above 13 °C
- Epitaxial  $\alpha$ -Sn on InSb stable to 130 °C
- Bandgap opens with strain
- Predicted to be a topological insulator
- 2D electron gas formed between  $\alpha$ -Sn and InSb
- Little studied since 1981

### Potential Applications

- Low-power, high-speed transistors
- Long-wavelength IR/THz detectors
- Phase-change memory material
- Non-polar active medium in III-V quantum-well heterostructures





## II. Novel GHz Electronics

- Less demanding on crystalline perfectness
- Deposition on almost any substrate at low temp.
- Radiation hard, fault tolerant, & self healing
- High electron concentration w/ correlated transport
- Wide bandgap for high power and transparency
- Topological effects
- SWAP-C and conforming
- Metal-insulator transition with high on-off ratio

1	1	H
2	3	Li
3	4	Be
3	11	Na
4	12	Mg
4	19	K
5	20	Ca
5	37	Rb
6	38	Sr
6	55	Cs
7	56	Ba
7	87	Fr
	88	Ra

21	22	23	24	25	26	27	28	29	30
Sc	Ti	V	Cr	Mn	Fe	Co	Ni	Cu	Zn
39	40	41	42	43	44	45	46	47	48
Y	Zr	Nb	Mo	Tc	Ru	Rh	Pd	Ag	Cd
71	72	73	74	75	76	77	78	79	80
Lu	Hf	Ta	W	Re	Os	Ir	Pt	Au	Hg
103	104	105	106	107	108	109	110	111	112
Lr	Rf	Db	Sg	Bh	Hs	Mt	Ds	Rg	Cn

Transition  
Metal  
Oxides,  
Chalcog-  
enides

5	6	7	8	9	10
B	C	N	O	F	Ne
13	14	15	16	17	18
Al	Si	P	S	Cl	Ar
31	32	33	34	35	36
Ga	Ge	As	Se	Br	Kr
49	50	51	52	53	54
In	Sn	Sb	Te	I	Xe
81	82	83	84	85	86
Tl	Pb	Bi	Po	At	Rn
113	114	115	116	117	118
Uut	Fl	Uup	Lv	Uus	Uuo

*Lanthanoids
**Actinoids

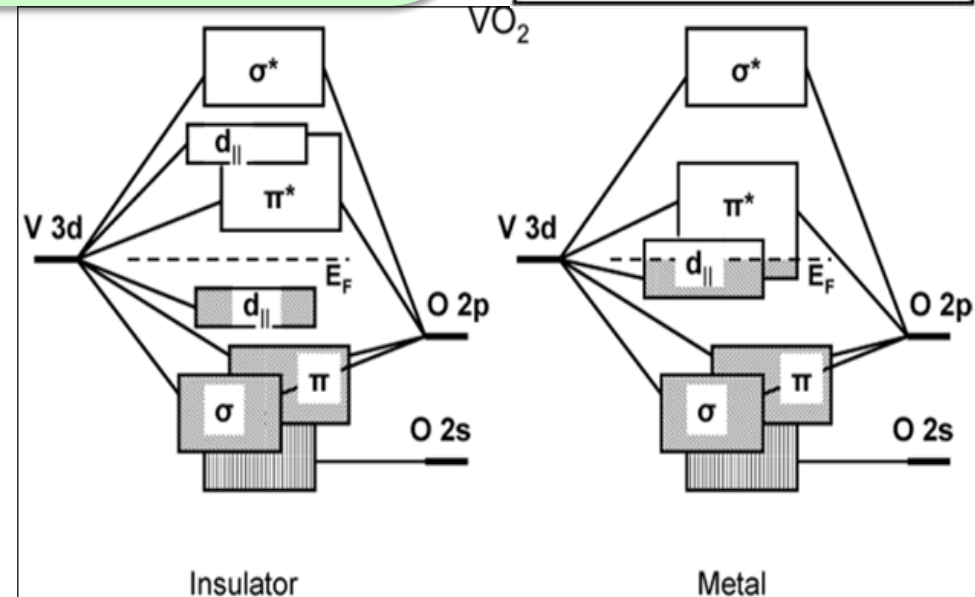
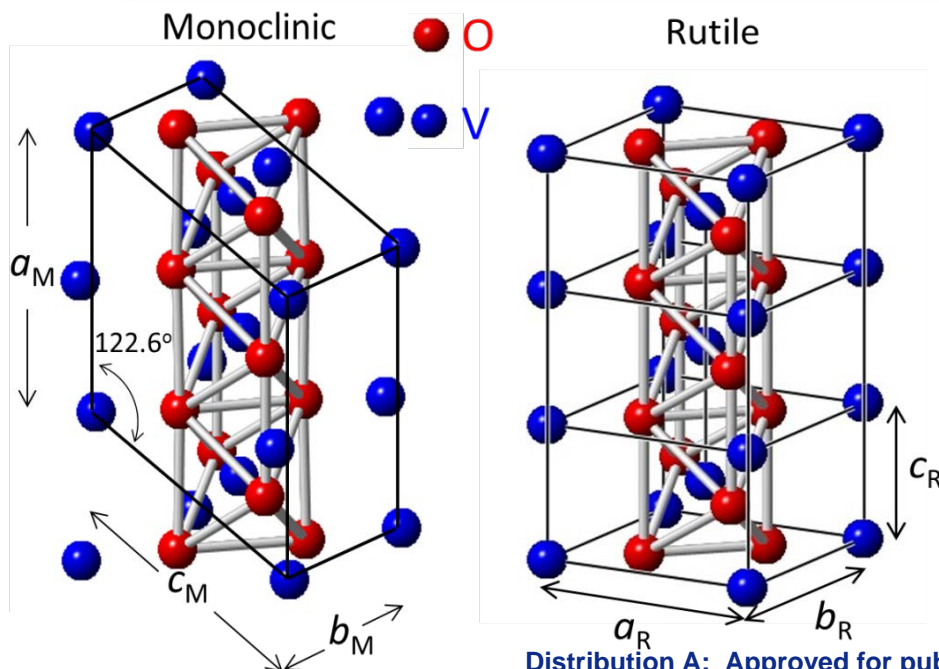
57	58	59	60	61	62	63	64	65	66	67	68	69	70
La	Ce	Pr	Nd	Pm	Sm	Eu	Gd	Tb	Dy	Ho	Er	Tm	Yb
89	90	91	92	93	94	95	96	97	98	99	100	101	102
Ac	Th	Pa	U	Np	Pu	Am	Cm	Bk	Cf	Es	Fm	Md	No



# Metal-Insulator Transition



- Observed in some bulk oxide crystals in late 1950s
- On/off conductivity ratio can be much higher than that of semiconductors ( $10^8$  vs.  $10^6$ )
- Requires little energy for switching at threshold
- Transition can be triggered by temperature, pressure, light, electric field, etc. and as fast as 100 fs
- What changes first? Structural or electronic?



J. B. Goodenough, JSSC, 1971



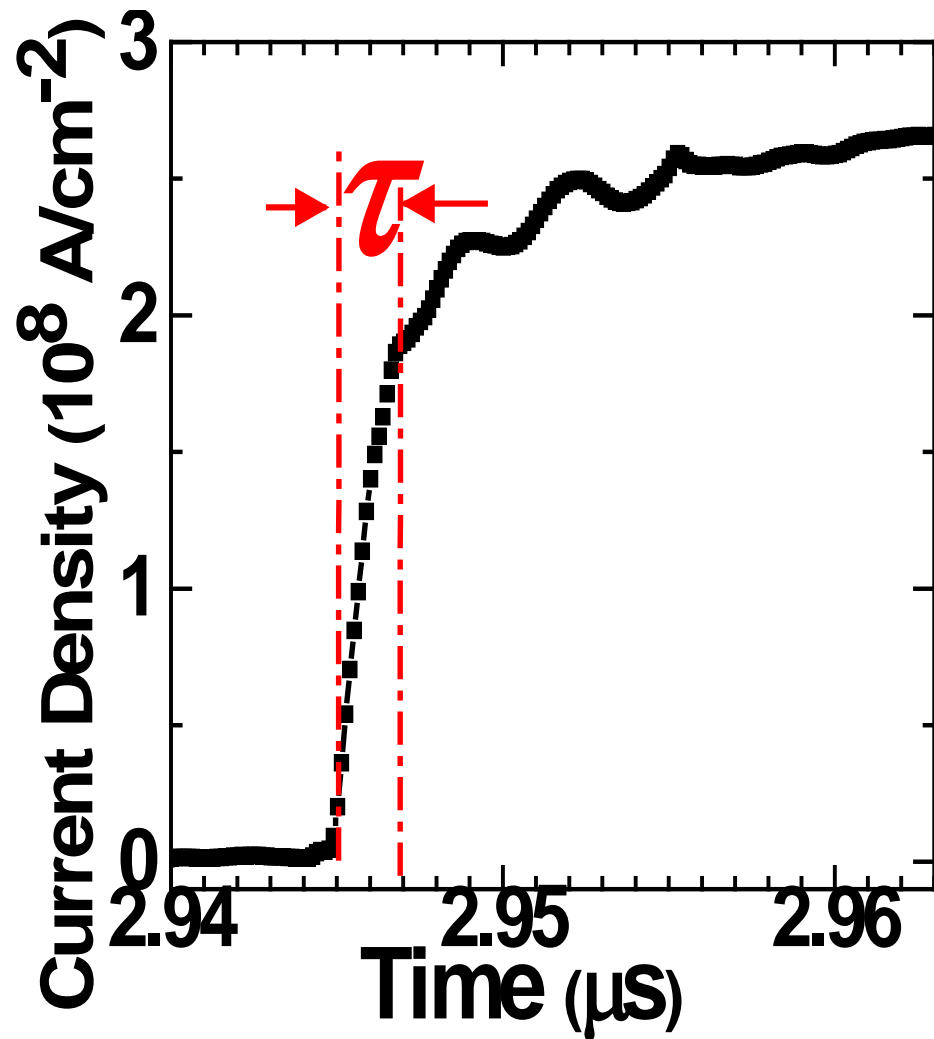
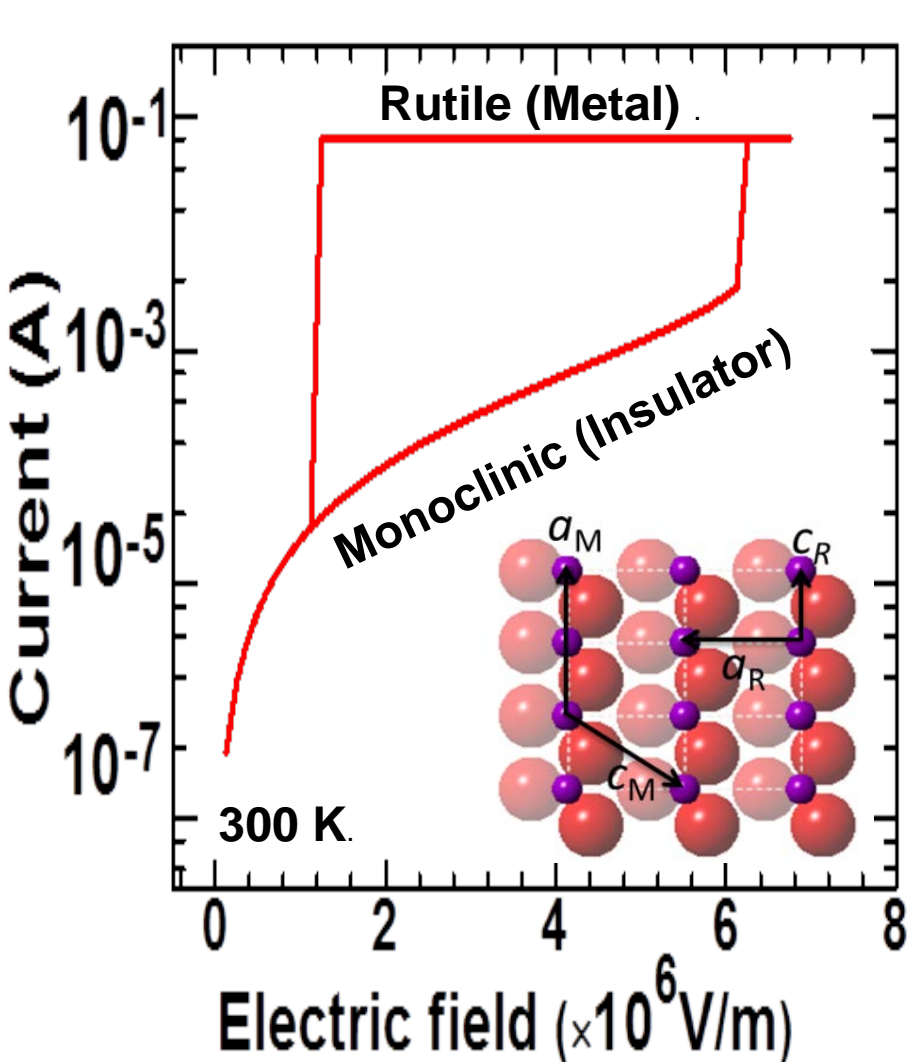


# Nanosecond Metal-Insulator Transition in $\text{VO}_2$

*Shriram Ramanathan (Harvard)*



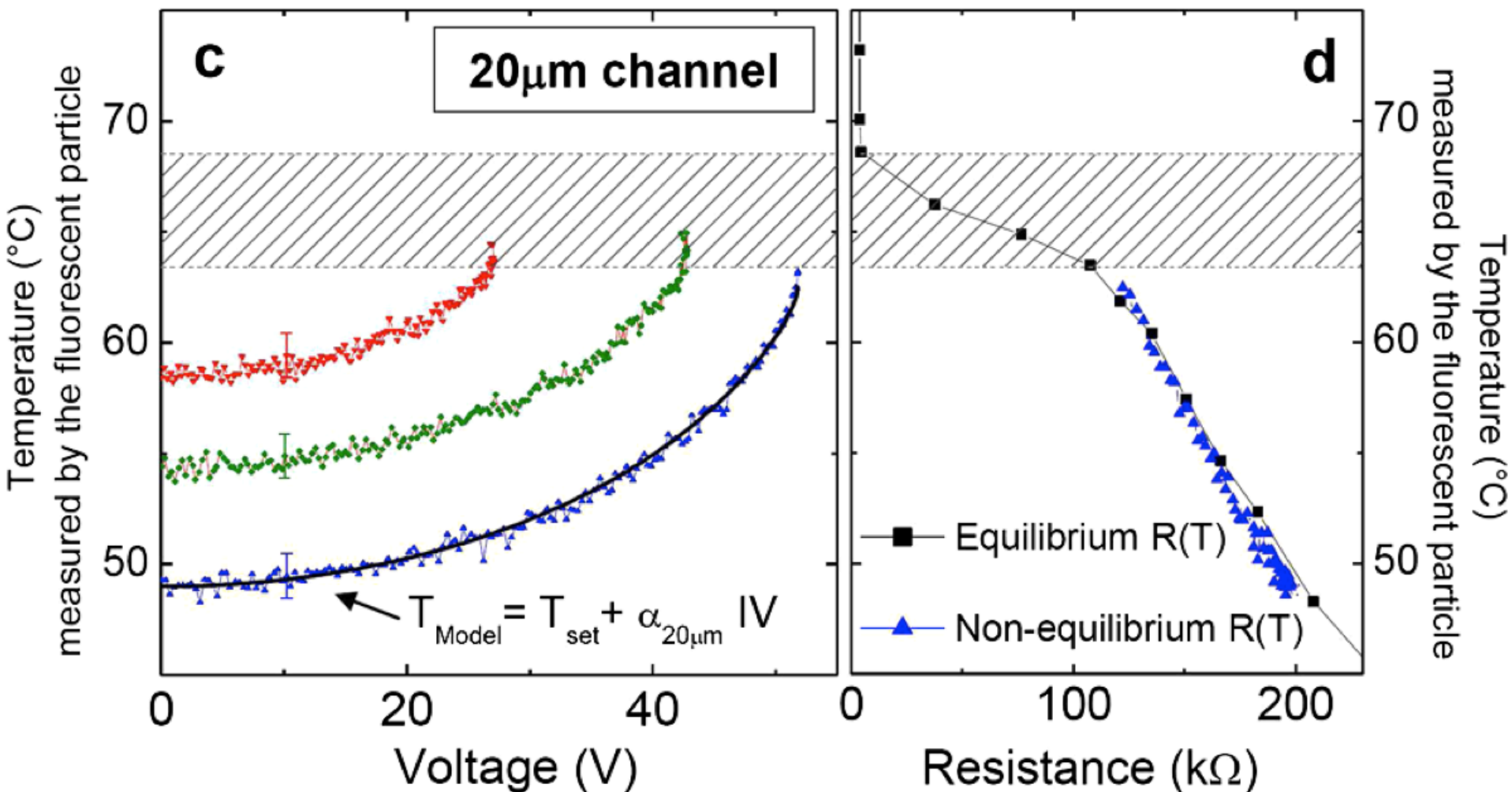
Polycrystalline  $\text{VO}_2$  on Au by RF-sputtering with precise control of  $\text{O}_2$  pressure





# Micro-Thermometry of Metal-Insulator Transition in $\text{VO}_2$

Ivan Schuller (UCSD)



**Voltage- or current-induced transition appears to be due to Joule heating**



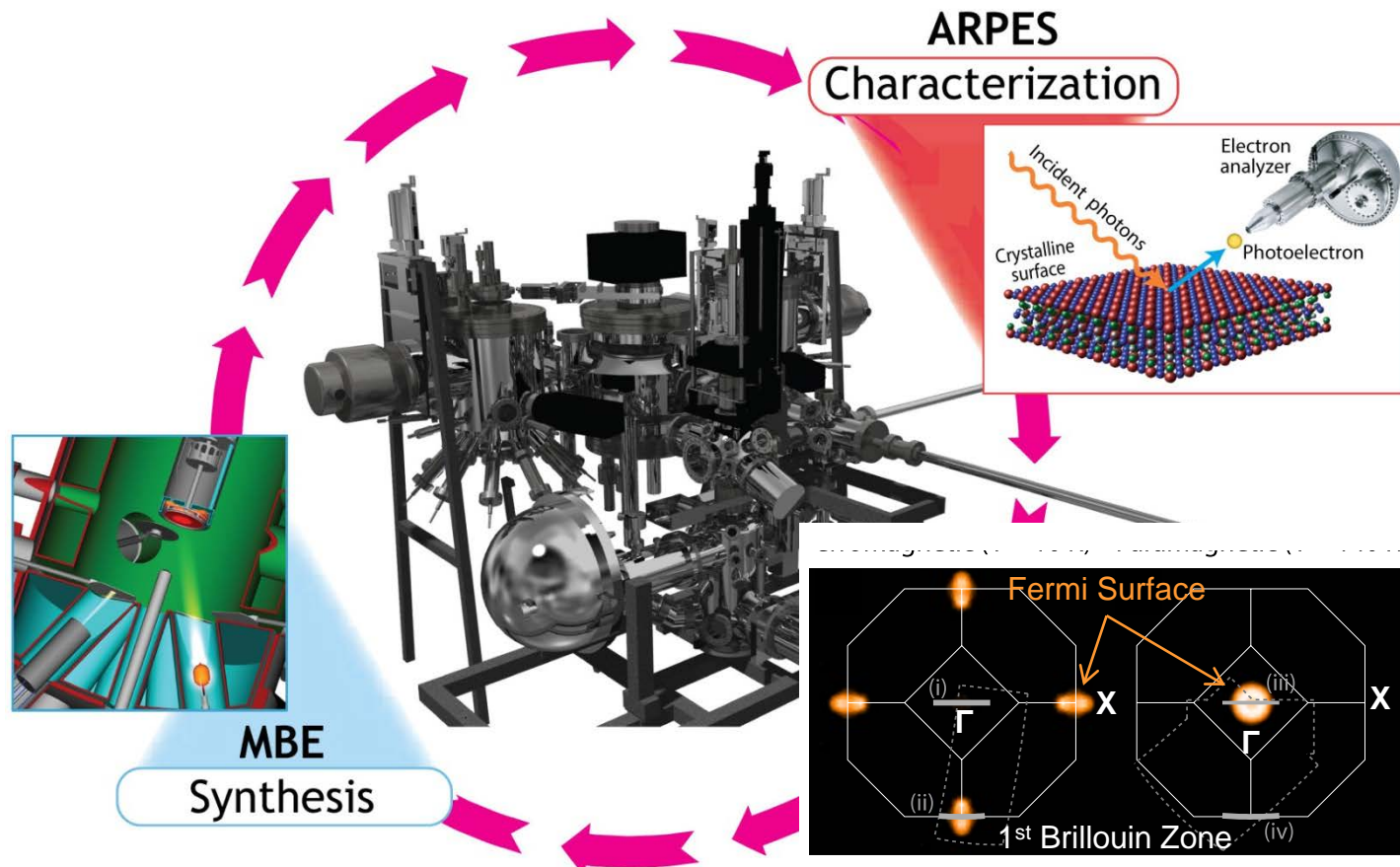
# Metal-Insulator Transition in EuO

## *Darrell Schlom & Kyle Shen (Cornell)*



Tight coupling of molecular-beam epitaxy (MBE) and angle-resolved photoelectron spectroscopy (ARPES) reveals metal-insulator transition involving massive Fermi surface reconstruction.

- Lack of carrier activation arises from defect states near  $\Gamma$  point.
- Reduce defects (including dopant clustering) to enable controlled doping.
- Combine strain and doping to boost Curie temperature.







# Collaboration



- Gernot Pomrenke – 2D materials & devices
- Harold Weinstock – nanoscale oxides
- Joycelyn Harrison – 2D materials
- Ali Sayir - oxides



- Dan Green – oxide electronics
- Paul Maki – nitride electronics
- Chagaan Baatar – 2D materials



- Marc Ulrich – topological insulators
- Pani Varanasi – 2D materials
- Mike Gerhold – transistor lasers



- Dev Palmer – THz & nitride electronics
- Jeff Rogers – topological insulators
- Brian Holloway – 2D materials



- Tony Esposito & Kiki Ikossi  
– THz applications



- Anu Kaul & Charles Ying  
– 2D materials & devices
- Dimitris Pavlidis  
– THz electronics



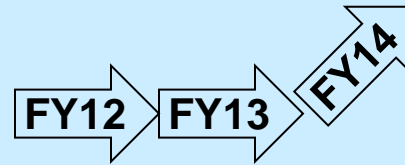
- Kwok Ng  
– beyond Si



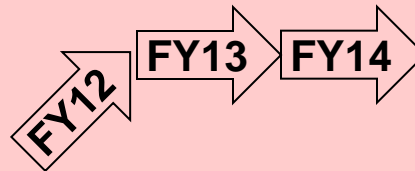


# Take-Away Messages

**I. THz Electronics –  
Explore 2D materials and devices**



**II. Novel GHz Electronics –  
Understand metal-insulator transition**



**III. Reconfigurable Electronics –  
Formulate strategy this year**

